

RECEIVED
CENTRAL FAX CENTER
JUN 08 2007

Amendment to the Specification

Please amend the title as follows:

METHOD OF POLYCRYSTALLIZATION, METHOD OF MANUFACTURING
POLYSILICON THIN FILM TRANSISTOR, AND LASER IRRADIATION DEVICE
THEREFOR

LAW OFFICES OF
MacPherson, Kwoh, Chen &
Brid LLP

2033 Gateway Plaza, Suite 400
San Jose, CA 95110
Telephone (408) 392-9230
Fax (408) 392-9262